

Notice of References Cited	Application/Control No. 10/679,154		Applicant(s)/Patent Under Reexamination SIMSKE ET AL.	
	Examiner James H. Blackwell		Art Unit 2176	Page 1 of 1

U.S. PATENT DOCUMENTS

*		Document Number Country Code-Number-Kind Code	Date MM-YYYY	Name	Classification
*	A	US-5,159,667 A	10-1992	Borrey et al.	715/500
*	B	US-5,767,978 A	06-1998	Revankar et al.	358/296
*	C	US-6,252,677 B1	06-2001	Hawes et al.	358/1.9
*	D	US-6,594,030 B1	07-2003	Ahlstrom et al.	358/1.15
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	K	US-			
	L	US-			
	M	US-			

FOREIGN PATENT DOCUMENTS

*		Document Number Country Code-Number-Kind Code	Date MM-YYYY	Country	Name	Classification
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NON-PATENT DOCUMENTS

*		Include as applicable: Author, Title Date, Publisher, Edition or Volume, Pertinent Pages)
	U	Cattoni et al., "Geometric Layout Analysis Techniques for Document Image Understanding: a Review", 01/1998, ITC-IRST, 68 pages
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*A copy of this reference is not being furnished with this Office action. (See MPEP § 707.05(a).)
Dates in MM-YYYY format are publication dates. Classifications may be US or foreign.